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OPEN Pseudo-Hydrogen Passivation: A **Novel Way to Calculate Absolute** Surface Energy of Zinc Blende (111)/(111) Surface

Yiou Zhang, Jingzhao Zhang, Kinfai Tse, Lun Wong, Chunkai Chan, Bei Deng & Junyi Zhu

Determining accurate absolute surface energies for polar surfaces of semiconductors has been a great challenge in decades. Here, we propose pseudo-hydrogen passivation to calculate them, using density functional theory approaches. By calculating the energy contribution from pseudo-hydrogen using either a pseudo molecule method or a tetrahedral cluster method, we obtained (111)/(III) surfaces energies of Si, GaP, GaAs, and ZnS with high self-consistency. This method quantitatively confirms that surface energy is determined by the number and the energy of dangling bonds of surface atoms. Our findings may greatly enhance the basic understandings of different surfaces and lead to novel strategies in the crystal growth.

Absolute surface energies are fundamental physical quantities of solid surfaces with broad implications¹⁻⁵. Equilibrium shapes and morphologies^{4,5}, equilibrium growth rates⁶⁻⁸, as well as device performance of semiconductors9, are directly related to them. The wetting conditions of thin films or super lattices are also determined by these quantities¹⁰. Novel controlling strategies of growth modes (e.g. by strain or surfactants) are also often determined by them¹⁰⁻¹⁸. Therefore, determining accurate absolute surface energy is essential in understanding growth processes and in improving the performance of thin-film devices^{3,19}.

Absolute surface energies of symmetric non-polar surfaces can be calculated with a standard slab method³. However, for asymmetric polar surfaces such as zinc blende (111) and $(\bar{1}\bar{1}\bar{1})$ surfaces, it is extremely difficult to separate the anion and cation terminated surfaces, due to the asymmetric nature of slabs^{3,19}. Although surface reconstructions and surface kinetic processes can be calculated by passivating the conjugate surfaces with pseudo-H atoms, the absolute surface energy can't be obtained unless the energy of the passivated surface is known^{3,19}. Despite the standard treatment of pseudo H passivation in surface calculations, a detailed analysis of the bonding between the surface atom and the pseudo H is lacking and may serve as a key to solve the difficult absolute surface energy problem. Chetty and Martin²¹ first proposed local energy density approach to determine the absolute surface energies of polar surfaces. However, this approach suffers from a non-trivial approximation of the local energy density³, which leads to a large disagreement among calculations using exactly the same method²⁰. Another early approach to calculate the absolute surface energies of zinc blende (111) surfaces is to construct a wedge structure and then calculate one polar surface without involving its conjugate surfaces³. Based on surface energies calculated by this approach, a common dangling bond rule was also proposed, which states that energies of surface atoms with similar electronic environment are the same regardless of the different surface orientations³. Following this method, absolute surface energies of quite a few compound semiconductors along different orientations are calculated^{3,19,22-26}. However, there are a few problems associated with this approach: (1) the surface energies may not be well defined near the edge or corner of the wedge, especially when the wedge size is small, therefore, the size of the wedge structure has to be quite large to reduce edge effect²², which makes this method rather expensive^{19,23}; (2) Pseudo-H near the edge may not be stable¹⁹, which may also affect the accuracy of the calculation. As a result, the calculated absolute surface energies have large errors up to $20 \text{ meV}/\text{\AA}^{219}$.

To overcome these problems, we propose a novel method to calculate the absolute surface energies of these surfaces using a pseudo-H passivation approach. Pseudo-H atoms are usually used in zinc blende slab calculations to passivate the dangling bonds of the bottom surface atoms. The pseudo-H atoms carry fractional charge to

Department of Physics, the Chinese University of Hong Kong, Hong Kong. Correspondence and requests for materials should be addressed to J.Z. (email: jyzhu@phy.cuhk.edu.hk)

maintain charge neutrality on the bottom surface, and also stabilize the bottom surface by satisfying electron counting rule $(ECR)^{27-29}$. This passivation ensures that states at the bottom surface are localized and have no interactions with top surface. The energy of the top surface can be directly calculated if the pseudo-H passivation energy can be evaluated. Therefore, a natural and intuitive way to calculate the absolute surface energy is to analyze the pseudo-H passivation process. We show that the energy of the passivated surface can be directly calculated from the pseudo chemical potentials of the pseudo-H atoms attached on the bottom surface. Further, our calculations show that simple pseudo-molecules already give reasonably accurate values of the pseudo chemical potentials. Surface energy calculated from this approach shows comparable self-consistency with the wedge structure calculation, while the computation is much simpler. For high accuracy calculations, we construct a tetrahedral cluster with four equivalent (111)/($\overline{111}$) facets to calculate the pseudo-H chemical potentials and the surface energies show improved self-consistency.

Consider a slab of a binary AB compound of zinc blende structure along [111] direction. The bottom ($\overline{1}\overline{1}\overline{1}$) surface with B-termination is passivated with pseudo-H atom carrying fractional charge denote as H_B. The absolute surface energy per unit area of the top (111) surface is then given by

$$\sigma_{top} = \frac{1}{\alpha_{111}} \Big[E_{slab} - n_A \mu_A - n_B \mu_B - n_{H_B} \mu_{H_B} - \alpha_{111} \sigma_{bot}^{pass} \Big], \tag{1}$$

where E_{slab} is the total energy of the slab with bottom surface passivated, $n_A(n_B)$ is the number of A(B) atoms in the slab, $\mu_A(\mu_B)$ is the chemical potential of A(B) atom, μ_{H_B} is the chemical potential of pseudo-H H_B, α_{111} is the area of (111) surface and σ_{bot}^{pass} is the surface energy of the passivated bottom surface. Assuming a thermodynamic equilibrium between the bulk and surface, we can write

$$\mu_A + \mu_B = E_{AB} = E_A + E_B + \Delta H_f(AB), \qquad (2)$$

where E_{AB} , E_A and E_B are total energy of corresponding bulk solid, and $\Delta H_f(AB)$ is the formation enthalpy of AB compound. To avoid presence of either solid A or solid B, it is required that $\Delta \mu_A = \mu_A - E_A$ satisfy

$$\Delta H_{\rm f}(AB) \le \Delta \mu_{\rm A} \le 0, \tag{3}$$

which the limits correspond to the A-poor and A-rich limit. On the right hand side (RHS) of Eq. (1), all terms can be easily determined from first-principle calculations except for μ_{H_B} and σ_{bot}^{pass} , which is the major focus of this Letter.

To calculate these terms, we define a pseudo chemical potential $\hat{\mu}_{H_B}$ for $\mathbf{H}_{\rm B}$ by considering the sum of two terms, so that

$$\mathbf{n}_{\mathrm{H}_{B}}\hat{\boldsymbol{\mu}}_{H_{B}} = \alpha_{111}\sigma_{\mathrm{bot}}^{\mathrm{pass}} + \mathbf{n}_{\mathrm{H}_{B}}\boldsymbol{\mu}_{\mathrm{H}_{B}},\tag{4}$$

and Eq. (1) can be rewritten as

$$\sigma_{\rm top} = \frac{1}{\alpha_{111}} \Big[E_{\rm slab} - n_{\rm A} \mu_{\rm A} - n_{\rm B} \mu_{\rm B} - n_{\rm H_B} \hat{\mu}_{H_B} \Big].$$
(5)

The pseudo chemical potential describes the energy gain from adding one pseudo-H atom and passivating one dangling bond on the bottom surface with this pseudo-H atom. This pseudo chemical potential can be decomposed into

$$\hat{\mu}_{H_{R}} = \mu_{H_{R}} + [\delta E_{int} + \delta E_{env}], \tag{6}$$

where the former part is the chemical potential of H_B atom, and the latter part in bracket is the binding energy between the surface atom and the pseudo-H atom. This binding energy is just the energy of the passivated surface, divided by the number of passivated bond rather than surface area. It can be further decomposed into δE_{int} due to the intrinsic property of the surface atom, and δE_{env} due to electronic environment. Since passivated surfaces satisfy charge neutrality and ECR^{25–27}, contribution from the environment is expected to be localized, and the major contribution comes from the local electronic environment around the pseudo-H atoms. It is difficult to calculate each individual part of the pseudo chemical potential, but the summation of all parts can be estimated under a local electronic environment similar to that of the surface atoms. This transforms the problem of calculating the energy of individual polar surface to a problem of estimating energy of bonds between surface atoms and pseudo-H atoms with a similar electronic environment. Such estimation only requires reproducing a local electronic environment similar to that of the surface atoms and pseudo-H atoms on the surface, but not the overall structure and symmetry of the surface. Therefore, this method is generally applicable to any crystal planes, as long as we can determine the pseudo chemical potential of H_B with the similar local environment on the surface. Also, if we passivate the top surface with pseudo-H atom H_A, left hand side (LHS) of Eq. (5) becomes $\sigma_{top}^{pass} = n_{H_A} \hat{\mu}_H / \alpha_{11P}$, and we obtain

$$n_{H_{A}}\hat{\mu}_{H_{A}} + n_{H_{B}}\hat{\mu}_{H_{B}} = E_{slab}' - n_{A}\mu_{A} - n_{B}\mu_{B},$$
(7)

where E'_{slab} denotes a total energy of the slab with both surfaces passivated. Eq. (7) describes the energy of all bonds between surface atoms and pseudo-H atoms, whereas LHS is calculated from pseudo chemical potentials





and RHS is from standard slab calculation. Therefore, Eq. (7) can be used to directly determine the difference between the obtained pseudo chemical potentials and the standard slab calculations, which defines the self-consistency of the calculation.

Here, we propose two ways to determine the pseudo chemical potential for the $(111)/(\bar{1}\bar{1}\bar{1})$ surface, one from a simple pseudo-molecule and the other from a tetrahedral cluster. For the pseudo-molecule method, we construct a CH₄-like molecule, with A(B) atom at the center of a tetrahedron bonded to four H_A(H_B) atom at the corner of the tetrahedron, as shown in Fig. 1(a). It can be viewed as passivating four dangling bonds of a free-standing atom by pseudo-H. Since there are four bonds between center atom and pseudo-H, we can determine the pseudo chemical potential by

$$\hat{\mu}_{H_A} = (E_{\text{molecule}} - \mu_A)/4 . \tag{8}$$

Using this method, the chemical potential of HA and intrinsic contribution to the binding energy can be calculated, but it does not reproduce the local electronic environment. This method is straightforward and computationally inexpensive, nevertheless yields a fairly accurate result. Thus, it can be taken as the 0th order approximation for the pseudo chemical potential of the pseudo-H.

The cluster method, in addition, reproduces local electronic environment similar to that on the surface. The structure is shown in Fig. 1(b) (for details of the tetrahedral clusters, please refer to the supporting information). The cluster contains four (111) facets and all the dangling bonds on the surface are passivated by the corresponding pseudo-H atoms. The size of the cluster can be identified by *n*, the number of atoms on the edge. From the figure, we can identify surface atoms with different local environment. For each A atom on the corner, it is bonded to one B atom and three H_A atoms; for each A atom on the edge but not on the corner, it is bonded to two B atoms and two H_A atoms; for each A atom on the face of the tetrahedron, it is bonded to three B atoms and one H_A atom (similar to (111) surface). We can denote the pseudo chemical potentials under these three conditions as $\hat{\mu}_{H_A}^{cor}$, $\hat{\mu}_{H_A}^{edge}$ and $\hat{\mu}_{H_A}^{face}$ respectively. Local electronic environment of H_A atoms on the face of the clusters is similar to that of H_A atoms on (111) surface. Therefore, $\hat{\mu}_{H_A}^{face}$ is a good approximation to $\hat{\mu}_{H_A}$ on (111) surface. Since number of A atoms, B atoms and pseudo-H atoms can all be expressed by the cluster size n, we write the total energy of the cluster as

$$\begin{split} E_{cluster}(n) &= \frac{1}{6} n(n+1)(n+2)\mu_A + \frac{1}{6} n(n-1)(n+1)(E_{AB} - \mu_A) \\ &+ 2(n-2)(n-3) \,\hat{\mu}_{H_A}^{face} + 12(n-2) \,\hat{\mu}_{H_A}^{edge} + 12 \,\hat{\mu}_{H_A}^{cor}, \end{split} \tag{9}$$

where E_{AB} here is explicitly taken as a variable allowing for small deviations from the bulk energy. Such a constant shift of bulk atom energy has previously been observed from standard slab calculations³⁰. By calculating four clusters of different size, we can solve the Eq. (7) and obtain $\hat{\mu}_{H_A}^{face}$ as a good approximation to $\hat{\mu}_{H_A}$ on (111) surface. Similarly, we can determine $\hat{\mu}_{H_B}$ on ($\bar{I} \bar{I} \bar{I}$) surface by swapping B with A, and H_A with H_B.

For a proof of principle, we considered three semiconductors, Si, GaP and ZnS. Both polar (111)/($\bar{1}\bar{1}\bar{1}$) surfaces, and non-polar (110) surfaces are calculated. Surface energy of (110) surface can be determined from the standard slab calculation, so this provides additional validity check with our method. Also, each surface atom on unreconstructed (110) surface contains one dangling bond, similar to (111)/($\bar{1}\bar{1}\bar{1}$) surface. To compare our results with previous works^{3,23}, we also calculated (111)/($\bar{1}\bar{1}\bar{1}$) surface of GaAs, as well as the wedge structure of GaAs. For (111)/($\bar{1}\bar{1}\bar{1}$) surface, only the absolute energy of Si surfaces can be calculated by constructing symmetric slabs. However, for compound semiconductors, we can construct slabs with both surfaces passivated, and calculate the energy of the fully passivated slabs, where two different kinds of pseudo-H atoms are involved. Then by making use of Eq. (7), we can obtain the sum of the pseudo chemical potentials with the standard slab calculations. The differences per surface area between the sum based on the cluster (or pseudo molecule) method and the slab method were used to check the self-consistency of our method as well as to estimate the errors of the obtained surface energies. The percentage differences were also calculated. Throughout the calculation, the chemical potentials of Ga and that of Zn are taken at the rich limit for GaP (GaAs) and ZnS, respectively.



Figure 2. A summary of results from pseudo-molecule method and tetrahedral cluster method. Both percentage differences and differences per surface area are calculated and listed. Vertical scale shows percentage differences between the obtained pseudo chemical potentials and slab calculations. Energy differences per surface area (meV/Å²) are labeled on the figure for each point.

Total energy calculations of bulks, slabs and clusters were based on Density Functional Theory^{31,32} as implemented in VASP code^{33,34}, with a plane wave basis set^{35,36}. The energy cutoff of the plane wave was set at 400 eV. PBE Generalized Gradient Approximation (GGA) functional³⁷ was used for GGA functional calculations. Construction of wedge structures strictly follows the method mentioned in ref. 3. Wedge structures with baseline index 7 and 8 are used to determine absolute surface energies of GsAs (111)/($\overline{111}$) surface. For GsAs (111)/($\overline{111}$) surface and wedge structure, calculations based on both GGA and Local Density Approximation (LDA) are performed. The obtained results are compared with previous works by both LDA functional³ and GGA functional²³. As GGA functional usually gives a smaller band-gap than experimental value, which affects the accuracy of the surface energies¹⁹, we also performed calculations with screened hybrid functional of Heyd, Scuseria, and Ernzerhof (HSE)^{38,39} on slabs and pseudo-molecules of GaP to test the difference between GGA functional and hybrid functional. Results indicate that our proposed method is general and is not functional dependent.

All the slab calculations were performed on (1×1) slabs, with $(10 \times 10 \times 1)$ Monkhorst-Pack⁴⁰ k-point mesh for integration over Brillouin zone for GGA calculations and $(4 \times 4 \times 1)$ for hybrid functional calculations. The slabs and clusters were separated by at least 15 Å vacuum. Pseudo-H atoms with charge q = 0.5e, 0.75e, 1.25e, and 1.5e were used to passivate dangling bonds of S, P (As), Ga, and Zn atoms, respectively. For Si, the passivation is done by true H. All the atoms in the slab and cluster were allowed to relax until forces converged to less than 0.005 eV/Å. Slabs along [111] direction contain 9 bi-layers, with both surfaces passivated by the corresponding pseudo-H atoms. Slabs along [110] direction contain 12 layers, and calculations were done both for slabs with both surfaces un-passivated and slabs with one surface passivated. Convergence tests are performed by increasing the number of layers in the slabs, and the results indicate that the obtained numerical errors of the surface energies are less than 0.5 meV/Å².

After the slab calculations, we calculated pseudo chemical potential by using pseudo-molecule method. We calculated the sum of the pseudo chemical potential of the pseudo H atoms that passivate the anion surface and the potential of the H atoms that passivate the cation surface. A comparison between the sums obtained by our method and that obtained by the slab method is shown in Fig. 2. For $111/(\bar{1}\,\bar{1}\,\bar{1})$ surface, difference between the slab calculations and the pseudo chemical potentials calculations are all within 6 meV/Å². Hybrid functional calculations of GaP show a difference of 9.1 meV/Å², slightly larger than that for GGA calculations. Calculations on (110) surfaces of Si, GaP and ZnS also show differences within 6 meV/Å². Previous calculations based on wedge structure have 3 meV/Å^{2 3} and 20 meV/Å^{2 19} differences for GaAs and zinc blend GaN respectively. Therefore, these results show good accuracies comparable to the wedge structure calculation, whereas the calculations are much simpler.

For the tetrahedral cluster method, although any four clusters can be used to solve for Eq. (8), different selections in fact give different results, as shown in Fig. 3. To make fair comparison between different systems, the percentage differences rather than differences per surface area were used. The variation of the results from clusters of different sizes is because we determine the pseudo chemical potentials from the energy differences between clusters. If energy differences between chosen clusters are large, the errors in the total energies of those clusters will be less significant. Hence the obtained pseudo chemical potentials will be more accurate. Therefore, in all the calculations, two smallest clusters and two largest clusters are chosen in the linear equation set to improve the accuracy. As can be seen from Fig. 3, the last three points show good convergence, with percentage differences less than 0.3% (1 meV/Å^2 in term of energy difference with that from bulk calculations. Therefore, we can take theses converged results as the pseudo chemical potentials obtained by cluster method, and the remaining differences as the errors of our method.



Figure 3. Differences between slab calculations of $111/(\overline{1}\,\overline{1})$ surfaces and pseudo chemical potentials obtained from different selections of clusters. The smallest clusters with n = 2 are always included and horizontal axis denotes the size of the largest cluster included. The difference between the Si (111) surface energy based on pseudo chemical potential calculation and that based on slab calculation is also included as a reference. Slight increase of differences at n = 9 for GaP and ZnS are mainly due to numerical errors between slab calculations and cluster calculations.

In addition, the differences between sum of the pseudo H chemical potentials obtained by the cluster method and that obtained by the slab method are summarized in Fig. 2. For both (111)/(11) and (110) surfaces of Si, GaP and ZnS, the differences are within $1 meV/Å^2$ with slab calculations, except for ZnS (110) surface. In particular, the difference of GaAs (111)/ $(\overline{1}\overline{1})$ surface is only 0.24 meV/Å². We also calculated this difference by wedge method with both LDA and GGA functional, to compare the self-consistency of tetrahedral cluster method and wedge method. For both LDA and GGA functional, differences of GaAs $(111)/(\overline{11})$ surface based on wedge structure method are around $3 meV/Å^2$, consistent with previous results³. Since the difference based on tetrahedral cluster method is one order of magnitude smaller than that based on wedge method, the tetrahedral cluster method shows better self-consistency and a higher accuracy than the wedge method does. To directly compare the absolute surface energies obtained by tetrahedral cluster method and that by wedge method in previous works^{3,23}, we also calculated the absolute surface energies of vacancy-terminated GaAs $(111)/(\overline{11})$ surface. By tetrahedral cluster method, we obtained $39.2 \, meV/\text{Å}^2$ for V_{Ga}-terminated (111)-2 × 2 surface, and $51.2 \, meV/\text{Å}^2$ for V_{As} -terminated ($\overline{1}\overline{1}\overline{1}$)-2 × 2 surface, whereas wedge structure method with GGA functional yields 45.2 meV/Å² and 52.7 meV/Å² respectively. This surface energy based on GGA functional by both tetrahedral cluster method and wedge method agrees reasonably well with recent works²³ by GGA functional (self-consistency check was not provided in ref. 23). Additionally, by using wedge method with LDA functional, we obtained 59.4 $meV/Å^2$ for V_{Ga} -terminated (111)-2 × 2 surface, and 69.5 meV/Å² for V_{As} -terminated ($\overline{111}$)-2 × 2 surface, which agrees with values obtained by Zhang and Wei³ (58 $meV/Å^2$ and 63 $meV/Å^2$ respectively). By comparing results of the same wedge structure calculations based on different exchange-correlation functional, we found that LDA and GGA functional yield different absolute surface energies, and large discrepancies between our results and previous work³ are mainly due to this reason. Additionally, the cluster method also works well for (110) surface as shown in Fig. 2. These results confirm that the number of pseudo-H atoms attached to each surface atom should be the major contribution to the pseudo chemical potential of pseudo-H.

From the estimation of pseudo chemical potential of pseudo-H atoms on (111)/($\bar{1}\bar{1}\bar{1}$) and (110) surfaces, we can see that major contributions of the pseudo chemical potential are from the chemical potential of pseudo-H $\mu_{H_{A/B}}$, and intrinsic contribution to the binding energy δE_{int} . The contribution from the local electronic environment, δE_{env} , is not significant. This is because on all the slabs and clusters, pseudo-H atoms have enough space to relax, and the surrounding local electronic environment only serves as a perturbation on the binding energy. Therefore, we have $\delta E_{env} \ll \mu_{H_{A/B}} + \delta E_{int}$. Also for δE_{env} the contribution from the 1st nearest neighbors of the surface atoms is much larger than that from the rest. Since the cluster method gives correct 1st nearest neighbors for surface atoms on both 111/($\bar{1}\bar{1}\bar{1}$) and (110) surfaces, both results are very accurate. This shows general applicability of the pseudo chemical potential to determine the absolute surface energy of polar surfaces, regardless of the overall geometry of the surfaces.

Several advantages can be achieved by using our proposed methods. Since pseudo-molecule method takes both the chemical potential of pseudo-H atoms and the intrinsic contributions to the binding energy between the pseudo H and the surface atoms, it has comparable accuracies as the wedge structure calculations. More importantly, this method is much simpler than the wedge method and can be easily applied to other surfaces, especially to polar surfaces other than $(111)/(\bar{1}\bar{1})$ surfaces, where wedges may be difficult to construct²³. The stability issues of the wedge methods can be avoided by the cluster methods, because of the high symmetry of the tetrahedral structures. The atomic structures are allowed to fully relax without constraints in all the cluster calculations. Therefore, the inaccuracy caused by instability of pseudo-H atoms and the finite size effects in wedge structure calculations can be largely avoided. Even though 4 clusters are essential for determining the surface energies while

	Si	GaP	ZnS
(111)	97.8(-0.4)	87.5	88.2
(111)	_	100.8	88.6
(110)	92.2(-1.0)	46.3(-0.4)	23.9(-2.1)

Table 1. Calculated absolute surface energies of unreconstructed (111), $(\bar{1}\bar{1}\bar{1})$ and (110) surfaces of Si, GaP and ZnS, based on pseudo chemical potentials from cluster method, in units of meV/Å². Values in parentheses are differences with surface energies calculated from standard slab calculation.

only two wedge structures are needed, two of the clusters are very small and easy to calculate. The large size difference between the large cluster and the small cluster greatly improves the accuracy of the method. Generally speaking, our methods are expected to save computing time and yield high accuracies.

From Table 1, we can conclude the general trends of the surface energies for different compounds. For unreconstructed $(111)/(\bar{1}\bar{1}\bar{1})$ surfaces, surface energies for Si, GaP and ZnS follow the trend of their cohesive energies, since the electron redistribution is not significant and surface energies are just directly determined by the dangling bonds on the surface. However, surface energies on (110) surfaces decrease sharply with the increase of the iconicity of the materials, because in those compounds, ECR can probably be better satisfied when electrons in cation dangling bonds are transferred to anion dangling bonds due to the large electronegativity difference between them^{27–29}. Also, the energy cost from forming the dimer-like structures on the surfaces is smaller for compounds with strong ionicity because the bond strength in such compounds is weaker than that in covalently bonded compounds.

In summary, we have proposed a new method to calculate surface energy of $(111)/(\bar{1}\bar{1}\bar{1})$ polar surface of zinc blende structure, based on pseudo-H passivation analysis. Tests on $(111)/(\bar{1}\bar{1}\bar{1})$ and (110) surface of Si, GaP and ZnS show very accurate results and good consistency with slab calculations. This method is not restricted to $(111)/(\bar{1}\bar{1}\bar{1})$ surfaces, and it is generally applicable to other surfaces of many other types of crystals. The 0th order approximation of the method yields reasonable accuracy that is comparable with wedge methods, but saves much computing time. The high order approach largely improves the accuracy of the absolute surface energy calculations. Since absolute surface energies are important to determine growth mode, wetting conditions, and crystal quality in hetero-structures of semiconductors, results from our methods are expected to provide very important physical insights in crystal growth techniques, thin film properties controls, and device performance enhancement. In particular, this method can give accurate surface energies of c/-c planes of wurtzite structures, where surface structures are similar to zinc blende $(111)/(\bar{1}\bar{1}\bar{1})$ surface, and absolute surface energies of the wurtzite polar surfaces can be determined from the pseudo-molecule or tetrahedral cluster method⁴¹.

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Author Contributions

J.Y.Z. supervised the project and designed the tetrahedral cluster shown in Figure 1(b). Y.O.Z. wrote the manuscript and performed calculations on Si and GaP. J.Z.Z. performed calculations on ZnS. K.F.T. designed the pseudo-molecule shown in Figure 1(a). L.W. performed calculations on GaAs with help from Y.O.Z. C.K.C. and B.D. joined the discussion and contributed constructive suggestions. All the authors reviewed the manuscript.

Additional Information

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